



PATENT
81864.0064

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mitsuru FUJII et al.

Serial No: 10/541,518

Filed: July 7, 2005

For: Pattern Formation Device, Pattern Formation
Method and Pattern Formation System

Art Unit: Not assigned

Examiner: Not assigned

PETITION FOR EXTENSION OF TIME

Mail Stop Petition
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence
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Name

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Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a two-month extension of time extending to July 10, 2006, the
period for response to the Notification of Missing Requirements dated February 9,
2006. A check for \$450.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: 

Lawrence J. McClure

Registration No. 44,228

Attorney for Applicant(s)

Date: July 10, 2006

500 South Grand Avenue, Suite 1900
Los Angeles, California 90071
Phone: 213-337-6700
Fax: 213-337-6701

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